

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:	)		
	Gardner et al.	)	Examiner:	Dupuis, Derek L.
Applio	eation No: 10/749,986	) )	Art Unit:	2883
Filed:	December 31, 2003	)		
For:	Microring and Microdisk Resonat For Lasers Fabricated on Silicon Wafers	ors ) )		
	RESPONSE TO NOTICE	OF NON	-COMPLIAN	T AMENDMENT
Comn P.O. É	Stop: Amendment hissioner for Patents Box 1450 ndria, VA 22313-1450			
Sir:				
	In response to the Notice of Non-C	ompliant	Amendments	to the Drawings mailed on
04/07/	2006, the Applicants respectfully re	equest tha	t the Examiner	enter the following
amend	lments and consider the following r	emarks.		
	FIRST CLASS	S CERTIFIC	CATE OF MAILIN	NG
mail wit	certify that I am causing the above-referenced	l correspond	ence to be deposite	d with the United States Postal Service as first classen addressed to the Commissioner for Patents, P.C.
		April 17, 2 Date of De		
			•	
	Name of Po	Pat Sullivan erson Mailin	g Correspondence	<del></del>
	Pat Salivan		April 17, 2006	
	Signature			Date

Attorney Docket No.: 42P18458 Application No.: 10/749,986